

Search Notes

Application/Control No.

10/509,435

Examiner

SANG KIM

Applicant(s)/Patent under
Reexamination

VUORISTO, TOMMI

Art Unit

3654

SEARCHED

Class	Subclass	Date	Examiner
242	530.1 533.2 533.7 542 542.3	1/17/2007	SK
242	532.2	1/17/2007	SK
242	534 534.2	1/17/2007	SK
242	598.1	1/17/2007	SK
242	598.3-.4	1/17/2007	SK
242	599.1	1/17/2007	SK
242	599.3	1/17/2007	SK

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
John Nguyen: 242/534, 534.2, 598.3-.4, 599.3, 542.3	1/17/2007	SK